



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Gaillard, et al.

Serial No.: 10/789,209

Confirmation No.: 9101

Filed: February 27, 2004

**For: Method of Decreasing the
K Value in SiOC Layer
Deposited by Chemical
Vapor Deposition**


Group Art Unit: 2818

Examiner: David Nhu

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING
37 CFR 1.8

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3/24/05 
Date Signature

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The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

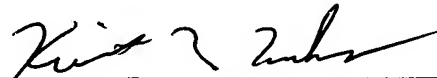
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In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

The Commissioner is hereby authorized to charge the sum of \$180.00 due under 37 CFR § 1.17(p) pursuant to § 1.97, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/2592.C9/KMT.

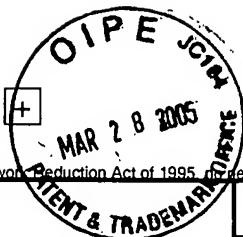
Respectfully submitted,



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PTO/SB/08a (08-03)

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Application Number	10/789,209
Filing Date	FEBRUARY 27, 2004
First Named Inventor	GAILLARD, ET AL.
Group Art Unit	2818
Examiner Name	DAVID NHU
Attorney Docket Number	AMAT/2592.C9/DSM/LOW K/JW
Submission Date	3/27, 2005

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
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	A2	6,825,130 B2	11/30/2004	TODD	
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	B1	EP 1 123 991 A2	08/16/2001	MICHAEL A. TODD		
	B2	EP 0 960 958 A2	12/01/1999	LOBODA, ET AL.		
	B3	EP 1 354 980 A1	10/22/2003	VRTIS, ET AL.		

Examiner

Date Considered

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